

Serial No.: 09/895,511

Patent

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

T. D. A. N	,
In Re Application of:)
Liang, Ted et al.)
U.S. Serial No: 09/895,511) Examiner: Zervigon, Rudy
Filed: June 29, 2001) Art Unit: 1763
For: APPARATUS FOR ELECTRON BEAM-INDUCED CHEMICAL ETCHING)) _)
Mail Stop RCE Commissioner for Patents P. O. Box 1450 Alexandria, VA 22313-1450	
PRELIMINA	RY AMENDMENT
Dear Sir:	
Applicants respectfully request t	that this Preliminary Amendment be entered
prior to examination of the above-ident	tified patent application.
I hereby certify that this correspondence is being deposited	RTIFICATE OF MAILING d with the United States Postal Service as first class mail with RCE, Commissioner for Patents, P.O. Box 1450, Alexandria, VA
	arch 6, 2006
Da	te of Deposit
	anne Neathery n Mailing Correspondence
Diame Neather	
Signature	3-6-06 Date
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